



EFK

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q76454

Shinji YOKONO, et al.

Appln. No.: 10/611,961

Group Art Unit: 1762

Confirmation No.: 3574

Examiner: James Lin

Filed: July 3, 2003

For: METHOD FOR MANUFACTURING PLASMA DISPLAY PANEL, INSPECTION  
METHOD FOR INSPECTING PHOSPOR LAYER AND INSPECTION APPARATUS  
FOR INSPECTING PHOSPHOR LAYER

**RESPONSE TO RESTRICTION REQUIREMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This responds to the Restriction Requirement, dated June 26, 2006. In response to the Restriction Requirement, Applicants elect Group I, claims 1-8 for examination. This election is made with out traverse.

Applicants reserve the right to file a Divisional Application directed to non-elected claims 9-14.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: July 26, 2006